

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : Unassigned  
Applicant : HEINE et al.  
Filed : Herewith  
TC/A.U. :  
Examiner :

**Docket No. : 2185-161**  
**Customer No. : 6449**

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:


Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith copies of publications that the Office may wish to consider in examination of the subject application. The publications are listed on the attached form PTO-1449.

DE 199 38 926 A1 discloses an optical system.

DE 200 22 603 U1 discloses a hand-held dermatological device.

DE 299 23 590 U1 discloses an optical device.

Respectfully submitted,

By   
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				<i>Complete if Known</i>			
				Application Number			
				Filing Date	Herewith		
				First Named Inventor	HEINE		
				Group Art Unit			
				Examiner Name			
Sheet	1	of	1	Attorney Docket Number	2185-161		
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
		Number	Kind Code <sup>2</sup> (if known)				
<b>FOREIGN PATENT DOCUMENTS</b>							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee of Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>
		Office <sup>3</sup> Code	Number <sup>4</sup>	Kind <sup>5</sup> (if known)			
	1	DE	199 38 926	A1	A. SCHWEIZER GmbH OPTISCHE FABRIK	07/12/2001	
	2	DE	200 22 603	U1	Rodenstock Prazisionsoptik GmbH & Co. KG	04/04/2002	
	3	DE	299 23 590	U1	LIFATEC GmbH FASEROPTIK UND OPTOELEKTRONIK	01/18/2001	
Examiner Signature					Date Considered		

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.